**Etcher - Plasma Etch PE-100LF**

- Description
- Configuration
- Training
- Location
- Contact

**Description**

200W Plasma etcher & cleaning system with oxygen and argon plasmas

**Configuration**

- 200W Etching system
- Two gases: Argon & Oxygen
- Dry vacuum pump

**Training**

Users may request training

**Location**

Lab: GCIS ESB26

**Contact**

Qiti Guo